

Electronic Patent Application Fee Transmittal

Application Number:	10516457			
Filing Date:	03-Dec-2004			
Title of Invention:	Heating jacket for plasma etching reactor, and etching method using same			
First Named Inventor/Applicant Name:	Michel Puech			
Filer:	David J. Cushing			
Attorney Docket Number:	Q84448			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Notice of appeal	1401	1	510	510
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 2 months with \$0 paid	1252	1	460	460
Miscellaneous:				
Total in USD (\$)				970